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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

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Li; Robert G. Palomba

Assignee

EnerNext, LCC

Title:

Method for Sorption and Desorption of Molecular Gas Contained by

Storage Sites of Nano-Filament Laded Reticulated Aerogel (As

Amended)

Serial No.:

10/666,663

Filing Date:

September 18, 2003

Examiner:

Ling Siu Choi

Group Art Unit:

1713

Docket No.:

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Confirmation No.:

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Irvine, California December 14, 2004

Via Facsimile to (703) 872-9306

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicants respectfully petition for a three (3)-month extension of time within which to respond to the First Office Action mailed July 1, 2004, such extension allowing the undersigned until January 1, 2005 to respond.

Please charge the amount of \$510.00 (for a small entity) as set forth in the accompanying Transmittal.

Certification of Facsimile Transmission

I hereby certify that this paper is being facsimile transmitted to the U.S. Patent and Trademark Office

on the date shown below. 1 Bulling

Monique M. Butler

December 14, 2004 Date of Signature

Tom Chen

Attorney for Applicants

Respectfully submitted,

Reg. No. 42,406

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